

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Sakae KOYATA et al. Group Art Unit : 1792
Appl. No. : 10/562,236 Examiner : Kin Chan Chen
Filed : February 7, 2007 Confirmation No. : 3799
For : MANUFACTURING METHOD OF SILICON WAFER

**COMPLETION OF RECORD
AND
STATEMENT OF INTERVIEW**

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop **Issue Fee**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Applicants express appreciation for the courtesies extended by Examiner Chen to Applicants' representative Arnold Turk during a September 10, 2009 telephone interview.

During the interview, Applicants' representative indicated that the Second Supplemental Information Disclosure Statement indicated that copies of English language translations of JP2002-025950 and JP05-226203 provided by Patent Abstracts of Japan (which include English abstracts and machine English translations) were being submitted and copies of these documents were submitted as they are present in private PAIR. However, the documents were inadvertently not listed on the Form PTO-1449 submitted with the Second Supplemental Information Disclosure Statement. The Examiner indicated that he would have considered the English abstracts and machine English translations along with the Japanese documents, because he does not read Japanese. Applicants' representative indicated that a completion of record would be filed including a Form PTO-1449 listing the English abstracts and machine English translations

in order that the Examiner can initial the form so that the record will reflect the Examiner's consideration on the face of the issued patent.

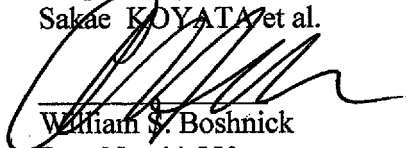
As the submission of the Second Supplemental Information Disclosure Statement was a bonafide submission, the documents are present in the record, and the Examiner has indicated that he would have considered the English abstracts and machine English translations when considering the Japanese documents, the Examiner is requested to initial the Form PTO-1449 being submitted herein. In this manner, the face of the issued patent will clearly reflect such consideration without the need to review the prosecution history to see that the documents are present in the file for consideration by the Examiner with the Japanese language documents.

Still further, this is to clarify that the Information Disclosure Statement and Supplemental Information Disclosure Statement were filed December 22, 2005 and December 24, 2008, respectively.

Authorization is provided herewith to charge any fee necessary for consideration and/or entry of this paper, including any fee for consideration of the Form PTO-1449 and the cited documents, to Deposit Account No. 19-0089.

If there should be any questions, the Examiner is invited to contact the undersigned at the telephone number listed below.

Respectfully Submitted,
Sakae KOYATA et al.



William S. Boshnick
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September 21, 2009
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